

Title (en)  
Orbitron-Pumpe.

Title (de)  
Orbitron-Pumpe

Title (fr)  
Pompe ionique de type Orbitron.

Publication  
**EP 1403903 A3 20050511 (DE)**

Application  
**EP 03015579 A 20030711**

Priority  
DE 10241549 A 20020905

Abstract (en)  
[origin: EP1403903A2] The miniature electron vacuum pump (10) has an emitter (22), extractor (20) connected to metallic foil (16) on glass insulation (14) and silicon base (12) on which the anode (26) is mounted to form a vacuum chamber (24) with an insulated (30) titanium cathode (28).

IPC 1-7  
**H01J 41/18**

IPC 8 full level  
**H01J 41/18** (2006.01)

CPC (source: EP)  
**H01J 41/18** (2013.01)

Citation (search report)

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Designated contracting state (EPC)  
AT BE BG CH CY CZ DE DK EE ES FI FR GB GR HU IE IT LI LU MC NL PT RO SE SI SK TR

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